



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Patent Application of

Koichiro TANAKA

Serial No. 09/774,637

Filed: February 1, 2001

For: BEAM HOMOGENIZER LASER
IRRADIATION APPARATUS,
SEMICONDUCTOR DEVICE,
AND METHOD OF FABRICATING)
THE SEMICONDUCTOR DEVICE)

) Group Art Unit: 2815

) Examiner: J. Diaz

)

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on 10-28-02

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INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

Washington, DC 20231

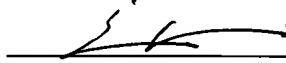
Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith a Form PTO-1449 listing references known to Applicant and requests that these references be considered by the Examiner and made of record in the above identified application. Copies of the references listed are submitted herewith in accordance with 37 C.F.R. 1.98(a).

The documents are being submitted before the first Office Action on the merits, therefore no fee or certification is required under 37 C.F.R. § 1.97(b).

The Commissioner is hereby authorized to charge any fees connected with this filing which may be required now, or credit any overpayment to Deposit Account No. 50-2280.

Respectfully submitted,


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